Notice of References Cited Application/Control No. 09/966,316 Examiner William C. Vesperman Applicant(s)/Patent Under Reexamination MIS ET AL. Art Unit Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6,415,974 ⁰	07-2002	Jao, Jui-Meng	228/215
	В	US-2002/0086520(0)	07-2002	Chiang, Ching Hua	438/630
	С	US-,162,257	11-1992	Yung, Edward K.	438/613
	D	US-6,208,018 p	03-2001	Ma et al.	257/669
	Ε	US-5,886,393 <i>∂</i>	03-1999	Merrill et al.	257/531
	F	US-5,902,686	05-1999	Mis, Joseph Daniel	428/629
	G	US-2002/0197842	12-2002	Kuo et al.	438/613
	Н	US-2003/0000738 A16	01-2003	Rumsey et al.	174/260
	ı	US-2002/0096764 (b)	07-2002	Huang, Min-Lung	257/737
	J	US-6,221,682 Ø	04-2001	Danziger et al.	438/15
	к	US-2001/0011764(b)	08-2001	ELENIUS et al.	257/679
	L	US-5,234,149	08-1993	Katz et al.	228/123.1
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р				,	
	Q					
	R					
	s					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	w	
	х	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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